

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang                      Art Unit : 2814  
Serial No. : 09/362,808                      Examiner : Shrinivas H. Rao  
Filed : July 28, 1999  
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 17, 2005

Please amend the above-identified application as follows:

The currently pending are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 13 of this paper.

**Remarks/Arguments** begin on page 14 of this paper.

An **Appendix** including amended drawing figures is attached following page 16 of this paper.